## **EAST Search History**

Ref #	Hits	Search Query	DBs	Default Operat or	Plural s	Time Stamp
L1	7371	anti\$1static near3 (((cinematographic radiographic photographic) adj film) film)	US-PGPU B; USPAT; USOCR; EPO; JPO; DERWEN T; IBM_TDB	OR	ON	2007/04/04 20:21
L2	81	1 and (static near3 (trouble defect outbreak))	US-PGPU B; USPAT; USOCR; EPO; JPO; DERWEN T; IBM_TDB	OR	ON	2007/04/04 21:07
L3	61	2 and (simulat\$3 measur\$3 test\$3)	US-PGPU B; USPAT; USOCR; EPO; JPO; DERWEN T; IBM_TDB	OR	ON	2007/04/04 20:22
L4	6	3 and (electrostatic near3 charge) and ((surface near3 resistivity) (surface near3 resistance))	US-PGPU B; USPAT; USOCR; EPO; JPO; DERWEN T; IBM_TDB	OR	ON	2007/04/04 21:00

## **EAST Search History**

					,	
L5		(step\$1wise with (chang\$3 alter\$5 differ\$4)) same (electrostatic near3 charge) same ((surface near3 resistivity) (surface near3 resistance))	US-PGPU B; USPAT; USOCR; EPO; JPO; DERWEN T; IBM_TDB	OR	ON	2007/04/04 21:02
L6	1	1 and 5	US-PGPU B; USPAT; USOCR; EPO; JPO; DERWEN T; IBM_TDB	OR	ON	2007/04/04 21:02
L7		5 not 6	US-PGPU B; USPAT; USOCR; EPO; JPO; DERWEN T; IBM_TDB	OR	ON	2007/04/04 21:03
L8	6406	((427/8) or (427/458) or (427/470) or (427/471) or (427/160) or (427/412.1) or (427/419) or (427/419.1) or (427/419.2) or (427/419.3) or (427/419.5)).CCLS.	US-PGPU B; USPAT; USOCR; EPO; JPO; DERWEN T; IBM_TDB	OR	OFF	2007/04/04 21:04
L10	33	1 and 8	US-PGPU B; USPAT; USOCR; EPO; JPO; DERWEN T; IBM_TDB	OR	ON	2007/04/04 21:06

## **EAST Search History**

L11	1	10 and simulat\$3	US-PGPU B; USPAT; USOCR; EPO; JPO; DERWEN T; IBM_TDB	OR	ON	2007/04/04 21:06
L12	2	8 and (static near3 (trouble defect outbreak))	US-PGPU B; USPAT; USOCR; EPO; JPO; DERWEN T; IBM_TDB	OR	ON	2007/04/04 21:07

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## Search Results Attached

Serial Number 10/682,540

Date <u>oyfoyfoor</u>

Total Pages of Results 2

CUPT-OY/OY/1207



Web Images Video News Maps more.»

("static marks" OR "static defects") AND (phote | Search

Advanced Scholar Search Scholar Preferences Scholar Help

Search only in Chemistry and Materials Science

Search in all subject areas.

The "AND" operator is unnecessary -- we include all search terms by default. [details]

Scholar Results 1 - 5 of 5 for ("static marks" OR "static defects") AND (photographic OR radiographic OR cinematographic) AND (anti-static OR antistatic) AND (simulation OR test OR simulation OR test OR simulation)

All Results

Fip: Looking for pictures? Try Google Images

M Takimoto

Photosensitive materials having improved antistatic property - group of 2.3 M Takimoto, T Saida, M Murata... - US Patent 4,495,276, 1985 - Google Patents

... photosensi- static marks are more likely to be generated. ... sensitive ing photographic

properties. ... without unproved antistatic property which comprises a sup- ...

Cited by 59 - Related Articles - Web Search

C Anderson M Murata T Saida

Y Wang

Silver halide photographic materials having improved anti-static properties - group of 2 » T Miyazako, I Toriya, M Hirose... - US Patent 4,126,467, 1978 - Google Patents ... static marks was carried out by placing a sample of the ... on the sup- 65 unexposed

photographic material on ... with the anti-static layer coated surface of the photo ...

Cited by 4 - Related Articles - Web Search

Photographic film with base containing polymeric antistatic material - group of 2 »

J Greener, D Majumdar, TM Laney - US Patent 6,207,361, 2001 - Google Patents ... one extruded layer comprising apolymeric anti-static material. ... fog pat -terns or

'static marks" in the ... as antistatic layers in photographic films comprising a ...

Cited by 5 - Related Articles - Web Search

Imaging element comprising an electrically-conductive layer containing conductive fine particles, a .... - group of 3 » CC Anderson, Y Wang, JL Bello, IM Shalhoub, DD ... - US Patent 5,466,567, 1995 - Google Patents ... s) can produce irregular fog pat -terns or "static marks" inthe emulsion. ... 4,078,935)

as being useful in antistatic layers for photographic applications. ...

Cited by 19 - Related Articles - Web Search

Imaging element comprising an electrically-conductive layer exhibiting improved adhesive ... - group of 3 »

M Lelental, J Greener - US Patent 5,508,135, 1996 - Google Patents

... s) can produce irregular fog pat -terns or "static marks" inthe emulsion. ... 4,078,935)

as being useful in antistatic layers for photographic applications. ...

Cited by 8 - Related Articles - Web Search

Search ("static marks" OR "static defects") 🗲 ©2007 Google